

	Application/Control No.	Applicant(s)/Patent under Reexamination
l	10/748,575	LEE, JOHN KAM HO
I	Examiner	Art Unit
İ	Van T. Trieu	2636

SEARCHED				
Class	Subclass	Date	Examiner	
340	500	5/20/2005	VT 1	
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
EAST	5/20/2005	VΤ	
Update Search	9/30/2005	VT	
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